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FORM 1449*	FORMATION DISCLOSURE STATEMENT	Docket Number: 14434.100USWO	Application Number: UNKNOWN		
IN AN APPLICATION  (Use several sheets if necessary)		Applicant: NAKAGAWA			
		Filing Date: CONCURRENT HEREWITH	Group Art Unit: UNKNOWN		

		U	.s. PATENT DOCUMENT	's			
EXAMINER INITIAL			NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	2003/0136964	7.24.2003	Afzali-Ardakani et al.			- M	<u> </u>
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	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
		l				YES	NO
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	Nakagawa pp. 2215-		force microscope for chemic	al sensing", J.	Vac. Sci. Techno	l. B 12(3), May/Ju	ine 199
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EXAMINER	/Colleen Rodgers/	,	DATE CONSIDERED	10/03/2008		

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.